

DOCKET NO: 279648US0PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
YOSHITAKE NATSUME, ET AL. : ATTN: APPLICATION DIVISION
SERIAL NO: NEW U.S. PCT APPLICATION :
BASED ON PCT/JP04/05527
FILED: HEREWITH :
FOR: NEGATIVE ELECTRODE FOR :
LITHIUM SECONDARY CELL,
LITHIUM SECONDARY CELL
EMPLOYING THE NEGATIVE
ELECTRODE, FILM DEPOSITION
MATERIAL B USED FOR
FORMING NEGATIVE
ELECTRODE, AND PROCESS FOR
PRODUCING NEGATIVE
ELECTRODE

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to examination on the merits, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.